Notice of Allowability	Application No.	Applicant(s)	-
	10/600,393	CHEN ET AL.	
	Examiner	Art Unit	
	Toniae M. Thomas	2822	
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate communing GHTS. This application is sure and MPEP 1308.	n the correspondence address this application. If not included nication will be mailed in due course. T	HIS itiative
1. This communication is responsive to the amendment filed of	<u>on 24 June 2005</u> .		
2. The allowed claim(s) is/are <u>1-33</u> .			
3. \boxtimes The drawings filed on <u>20 June 2003</u> are accepted by the E	xaminer.		
 Acknowledgment is made of a claim for foreign priority una	been received. been received in Application currents have been received of this communication to file a	No in this national stage application from t	
5. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give	es reason(s) why the oath or		=
 6. CORRECTED DRAWINGS (as "replacement sheets") mus (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the 	on's Patent Drawing Review s Amendment / Comment or i	n the Office action of	
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT I	Sit of BIOLOGICAL MATE FOR THE DEPOSIT OF BIOI	RIAL must be submitted. Note the LOGICAL MATERIAL.	
 Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/06 Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material 	6. ☐ Interview Sur Paper No./M 8), 7. ☐ Examiner's A		

Reasons for Allowance

The following is an examiner's statement of reasons for allowance: the prior art of record does not anticipate, teach or suggest a method of forming multiple gate insulator layers on a semiconductor substrate having a core region and an I/O region substantially as claimed, wherein the method comprises: removing the first insulator from the I/O region of the substrate, resulting in a first gate insulator having a first thickness located on the core region of the substrate; and selectively forming a second gate insulator having a second thickness on the I/O region of the substrate, as recited in claim 1. Moreover, the prior art of record does not anticipate, teach or suggest a method of forming multiple thickness gate insulator layers on a silicon-containing substrate substantially as claimed, wherein the method comprises: selectively removing, using a photoresist shape, a first dielectric layer from a second portion of the substrate resulting in a first gate insulator layer, having a first thickness, located on a first portion of the substrate; then removing the photoresist shape; and, then performing a second hydrofluoric (HF) pre-clean procedure, as recited in claim 20.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Art Unit: 2822

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Toniae M. Thomas whose telephone number is (571) 272-1846. The examiner can normally be reached on Monday through Friday from 8:30 a.m. to 5:30 p.m.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Amir Zarabian can be reached on (571) 272-1852. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

тмт 11 July 2005

> Mary Wilczewski Primary Examiner